

# Imec demonstrates extremely high-speed heterojunction bipolar transistors

October 11 2011

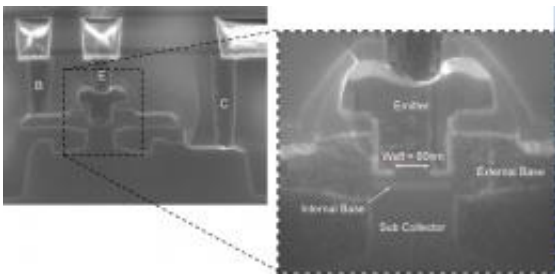
Parameter	Unit	Meas. condition	
Peak $f_T$	GHz	$V_{CB} = 0.5V$	245
Peak $f_{MAX}$	GHz	$V_{CB} = 0.5V$	450
Current gain	-	$V_{BE} = 0.75V$	400
$BV_{CEO}$	V	$V_{BE} = 0.7V$	1.7
$BV_{EBO}$	V		2.3
$BV_{CBO}$	V		5.1
$V_A$	V	$V_{BE} = 0.7V$	> 200
$C_{bc}$	fF	$V_{CB} = 0V$	1.75
$C_{be}$	fF	$V_{BE} = 0V$	2.1
$R_c$			60
$R_b$		@ peak $f_T$	35

Electrical parameters for a 0.15x1.0 $\mu$ m<sup>2</sup> HBT device

Imec realized a  $f_T/f_{MAX}$  245GHz/450GHz SiGe:C heterojunction bipolar transistor (HBT) device, a key enabler for future high-volume millimeter-wave low-power circuits to be used in automotive radar applications. These HBT devices also pave the way to silicon-based millimeter wave circuits penetrating the so-called THz gap, enabling enhanced imaging systems for security, medical and scientific applications

The extremely high-speed devices have a fully self-aligned architecture by self-alignment of the emitter, base and collector region, and

implement an optimized collector doping profile. Compared to III-V HBT devices, SiGe:C HBTs combine high-density and low-cost integration, making them suitable for consumer applications. Such high-speed devices can open up new application areas, working at very high frequencies with lower [power dissipation](#), or applications which require a reduced impact of process, voltage and [temperature variations](#) at lower frequencies for better circuit reliability.



Cross-section of bipolar HBT device in a B-E-B-C configuration after end-of-line processing

To achieve the ultra high-speed requirements, state-of-the-art SiGe:C HBTs need further up-scaling of the device performance. Thin sub-collector doping profiles are generally believed to be mandatory for this up-scaling. Usually, the collector dopants are introduced in the beginning of the processing and thus exposed to the complete thermal budget of the process flow. This complicates the accurate positioning of the buried collector. By in-situ arsenic doping during the simultaneous growth of the sub-collector pedestal and the SiGe:C base, imec introduced both a thin, well controlled, lowly doped collector region close to the base and a sharp transition to the highly doped collector without further complicating the process. This resulted in a considerable increase of the overall HBT device performance: Peak  $f_{MAX}$  values above 450GHz are obtained on devices with a high early voltage, a  $BV_{CEO}$  of 1.7V and a

sharp transition from the saturation to the active region in the IC-VCE output curve. Despite the aggressive scaling of the sub-collector doping profile, the collector-base capacitance values did not increase much. Moreover, the current gain is well defined, with an average around 400 and the emitter-base tunnel current, visible at low VBE values, is limited as well.

Provided by IMEC

Citation: Imec demonstrates extremely high-speed heterojunction bipolar transistors (2011, October 11) retrieved 11 May 2024 from <https://phys.org/news/2011-10-imec-extremely-high-speed-heterojunction-bipolar.html>

This document is subject to copyright. Apart from any fair dealing for the purpose of private study or research, no part may be reproduced without the written permission. The content is provided for information purposes only.